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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Plat et al.  
Serial No.: 10/079,775  
Filed: February 19, 2002  
Group Art Unit: 2823  
Before the Examiner: Lee, Hsien Ming  
Title: A METHOD FOR REDUCING ANTI-REFLECTIVE  
COATING LAYER REMOVAL DURING REMOVAL OF  
PHOTORESIST

**REPLY UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action having a mailing date of January 10, 2005, having a three-month shortened statutory period for response set to expire on April 10, 2005, please reconsider the rejections of the claims in view of the following remarks:

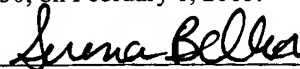
**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks** begin on page 11 of this paper.

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**CERTIFICATION UNDER 37 C.F.R. § 1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on February 1, 2005.

  
\_\_\_\_\_  
Signature

Serena Beller  
\_\_\_\_\_  
(Printed name of person certifying)

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